

Semiconductor
Chamber Parts

Precision Cleaning & Protective Coating











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Chamber Parts
Precision Cleaning
Protective Coating





CAGR (Unit: %)

971,090

2022 Cleaning & Coating Parts (Unit : EA)



738

Employees (Unit : Persons)



Cleaning & Coating
Professional R&D Staff
(Unit : Persons)



69

Patent (Unit : EA)

WE PROVIDE

QUALIFIED SERVICE



Service.01

Increase Semiconductor Yield & Parts Lifetime



Service.02 **ERP Tracking Management Infra**

Our ultra-precision cleaning and ultra-density coatings improve semiconductor yield, Parts lifetime and cost competitiveness.

A centralized control system capable of managing and operating all work process with 24/7 control





Service.03 **Providing Customized Solutions**

Based on accumulated technology and quality, we provide the most suitable ultra-precision cleaning & ultra-density coating



Service.04 **Precision Analysis** & Verification

Advanced analytics equipment and specialized research create futureleading technology quality and customer -trusted services

Our **Customers**











GLOBAL NETWORK

With, Global Analysis Lab ChemTrace





ICP-MS



LASER PARTICLE COUNTER



ION-CHROMATOGRAPHY



ATD-GC-MS



SEM-EDS



GC-MS

ChemTrace operates an independent commercial lab inside the CINOS C1 Facility in Hwaseong, South Korea

OUR SERVICE

PRECISION CLEANING

Pre-Cleaning

CAUSTM/ CISTM&DISTM PBCTM/ POCTM



Remove By-Product on the Parts Surface



Damage Free



Specialized in ShowerHead Cleaning Technology

Selective Cleaning

PSCTM / MPSTM / TICTM / PBRTM



Micro Particle Control



Metallic Ion Free

Post-Cleaning

SBCTM / SSCTM/ Warm-NPPTM



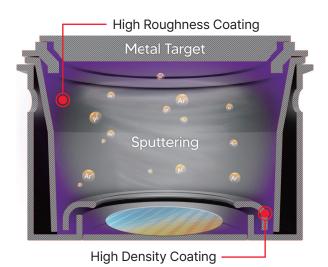
Nano Particle Control



Out-Gassing Free

PROTECTIVE COATING

Metal Process



High Roughness

ARC® Stealth™-1 HEMI™

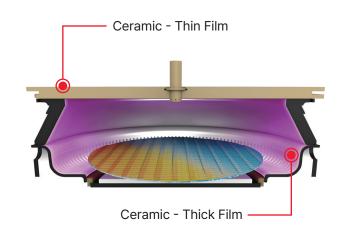
High Density

Stealth[™]-2 MAHA[™]



✓ Protect Base Material

Etch Process



Thin Film

EP-ZERON™ A-ZERON™

Thick Film

APS UHD™-1

UHD™-2

 SAC^{TM}

INDEPENDENT ANALYSIS

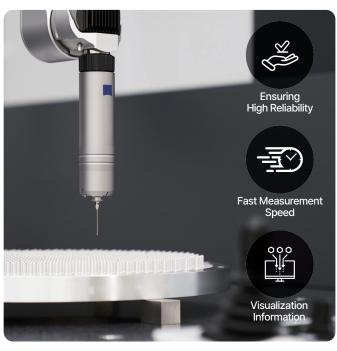
Particle Detection

- CPDS (Cinos Particle Detection System)



Geometric Tolerance

- Contact & Non-contact type CMM



Hole Uniformity

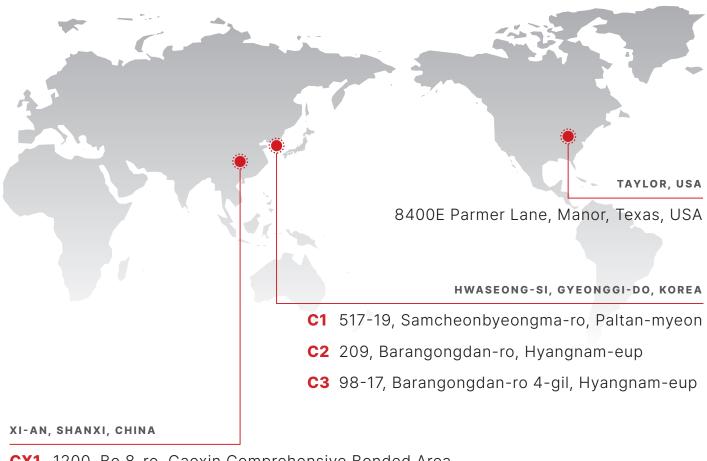
- HIS (Hole Inspection System)



Image Analysis

- Automatic Laser Confocal Microscope
- CTI (Coating Termination Inspection)





CX1 1200, Bo 8-ro, Gaoxin Comprehensive Bonded Area

CX2 1680, Jong 3-ro, Gaoxin Comprehensive Bonded Area

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